# RECEIVED **CENTRAL FAX CENTER**

SEP 3 0 2005

PEK-Inl178 D

### CERTIFICATION OF MAILING OR FAX TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 or facsimile transmitted to the U.S. Patent and Trademark Office on the date shown below.

Date:

September 30, 2005

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No.

: 10/815,407

Confirmation No. 7982

Applicant

: Jürgen Holz

Filed

: April 1, 2004

TC/A.U.

: 2822

Examiner

: Mark V. Prenty

Title:

: Method for Fabricating a Semiconductor

Structure Using a Protective Layer, and

Semiconductor Structure

Docket No.

PEK-In1178 D

Customer No.

24131

Hon. Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

#### **AMENDMENT**

### Sir:

In response to the Office action dated July 28, 2005, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 8 of this paper.